

OSMM&N File No. 230420US26YA

Dept.: E/M

By: SPW/RAR/csc

Serial No. 10/673.583

In the matter of the Application of: Andrej S. MITROVIC

For: SYSTEM AND METHOD FOR USING FIRST-PRINCIPLES SIMULATION  
TO PROVIDE VIRTUAL SENSORS THAT FACILITATE A  
SEMICONDUCTOR MANUFACTURING PROCESS

Due Date: July 6, 2007

The following has been received in the U.S. Patent Office on the date stamped here

- ☒ Request for Continued Examination
- ☒ Credit Card Form for \$790.00
- ☒ Dep. Acct. Order Form
- ☒ Amendment under 37 C.F.R. §1.114



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